

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Rejda, et al.

Date: September 10, 2003

Serial No.: Herewith

Docket No.: STL 11004.00

Filed: Herewith

Examiner: Not Yet Assigned

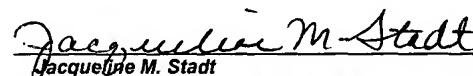
Title: SELECTIVE ETCHING DEVICE

Art Unit: Not Yet Assigned

CERTIFICATION UNDER 37 C.F.R. 1.10

"Express Mail" Mailing Label Number: EV 351133959 US
Date of Deposit: September 10, 2003

I hereby certify that this Information Disclosure Statement and the documents referred to as being attached are being deposited with the United States Postal Service on this date in an envelope as "Express Mail Post Office to Addressee" service under 37 C.F.R. 1.10 on the date indicated above and is addressed to the Commissioner for Patents, Mail Stop Patent Application, Alexandria, VA 22313-1450.


Jacqueline M. Stadt

INFORMATION DISCLOSURE STATEMENT

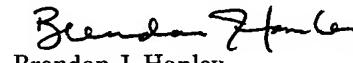
Mail Stop: Patent Application
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Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, and in accordance with the practice under 37 C.F.R. § 1.97 and § 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed information are also enclosed.

The submission of reference(s) being cited should in no way be construed as an admission that the reference(s) are relevant to 35 USC 102 or 103 but are merely submitted in accordance with 37 C.F.R. §1.56.

Respectfully submitted,


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Form PTO-1449 (REV 8-83)		DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	SERIAL NO. Herewith	ATTY DOCKET NO. STL 11004.00
INFORMATION DISCLOSURE CITATION (USE SEVERAL SHEETS IF NECESSARY) PAGE 1 OF 1		APPLICANTS Ed F. Rejda et al.		
		FILING DATE Herewith	GROUP Not Yet Assigned	

U.S. PATENT DOCUMENTS

E.I.	DOCUMENT NUMBER		DATE	NAME	CLASS	SUBCLASS	FILING DATE
	AA 4,549,238		10/22/85	Ertingshausen, et al	360	103	1/10/83
	AB 5,118,577		6/2/92	Brar et al	428	409	7/3/89
	AC 6,027,660		2/22/00	Hsiao et al	216	22	5/11/98
	AD 5,563,752		10/8/96	Komuro et al	360	113	9/8/94
	AE 5,883,770		3/16/99	Biskeborn et al	360	130.21	7/18/97
	AF 6,252,741 B1		6/26/01	Ahn, Junghi	360	235.1	5/11/99
	AG 6,199,267		3/13/01	Koshikawa et al	29	603.15	3/31/99
	AH 5,916,423		6/29/99	Westwood, John David	204	192.32	5/6/97
	AI 6,063,244		5/16/00	Pinarbasi, Mustafa	204	192.11	5/21/98
	AJ 6,197,164		3/6/01	Pinarbasi, Mustafa	204	192.11	10/10/97
	AK 6,335,063		1/1/02	Chen et al	427	558	10/20/99
	AL 6,170,149		1/9/01	Oshiki et al	29	603.09	1/30/97
	AM 5,903,968		5/18/99	Shouji, Shigeru	29	603.09	3/23/95
	AN						
	AO						
	AP						
	AQ						
	AR						

FOREIGN PATENT DOCUMENTS

E.I.	DOCUMENT NUMBER		DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
	AS						

OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)

AT	Diane K. Stewart, J. David Casey, Jr., <u>Handbook of Microlithography, Micromachining, and Microfabrication: Volume 2: Micromachining and Microfabrication</u> , Ch. 4, 153-195 (1999)
AU	P.E. Russell, T.J. Stark, D.P. Griffis, J.R. Phillips, and K.F. Jarausch, <u>Chemically and Geometrically Enhanced Focused Ion Beam Micromachining</u> , J. Vac. Sci. Technol. B 16(4), 2494-2498 (Jul/Aug 1998)

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.